

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
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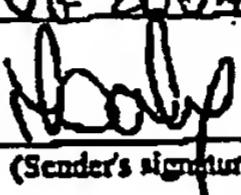
Art Unit: 3723

Title: POLISHING PAD FOR
ELECTROCHEMICAL-MECHANICAL
POLISHING

APR 04 2005

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA, 22313-1450

RESPONSE AND ELECTION

In response to the Office Action of July 28, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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